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TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>	Application Number	10/017,262	
	Filing Date	December 14, 2001	
	First Named Inventor	David L. Adler	
	Group Art Unit	2878	
	Examiner Name	not yet known	
Total Number of Pages in This Submission	3	Attorney Docket Number	P960 (11.700)

ENCLOSURES (check all that apply)					
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment / Response <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input checked="" type="checkbox"/> Transmittal Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): Preliminary Amendment Under 37 C.F.R. § 1.115; Return receipt postcard			
<table border="1"> <tr> <td>Remarks</td> <td rowspan="2"> RECEIVED AUG 22 2002 TECHNOLOGY CENTER 2800 </td> </tr> <tr> <td> </td> </tr> </table>			Remarks	RECEIVED AUG 22 2002 TECHNOLOGY CENTER 2800	
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	James K. Okamoto, Reg No. 40,110 DEGUZMAN OKAMOTO & BENEDICTO, LLP
Signature	
Date	August 2, 2002

CERTIFICATE OF MAILING			
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on this date: August 2, 2002			
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: Not yet known

David L. Adler, et al.

Serial No. 10/017,262

Art Unit: 2878

Filing Date: 12/14/2001

Attorney Docket No.: P960 (11.700)

Title: Photoelectron Emission Microscope for Wafer and Reticle Inspection

Honorable Commissioner of Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT UNDER 37 C.F.R. § 1.115

Sir:

This Preliminary Amendment is filed under 37 C.F.R. § 1.115 for the above-referenced patent application.

In The Specification:

Please amend the specification by inserting as the first paragraph following the title:

This Application claims the benefit of U.S. provisional patent application number 60/338,711, filed November 30, 2001, by inventor David L. Adler, entitled "A Photoelectron Emission Microscope for Wafer and Reticle Inspection."

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